

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/812,111	ARMSTRONG ET AL.	
	Examiner	Art Unit	Page 1 of 1
Lee Fineman	2872		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0040722 A1	11-2001	SHAFER et al.	359/351
*	B	US-4,108,794	08-1978	Yonekubo, Ken	252/408.1
*	C	US-5,825,043	10-1998	Suwa, Kyoichi	250/548
*	D	US-2004/0165257 A1	08-2004	Shafer et al.	359/366
*	E	US-2004/0240047 A1	12-2004	Shafer et al.	359/366
*	F	US-5,717,518	02-1998	Shafer et al.	359/357
*	G	US-5,159,495	10-1992	Hamblen, David P.	359/731
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.